

SENSORS and TRANSDUCERS

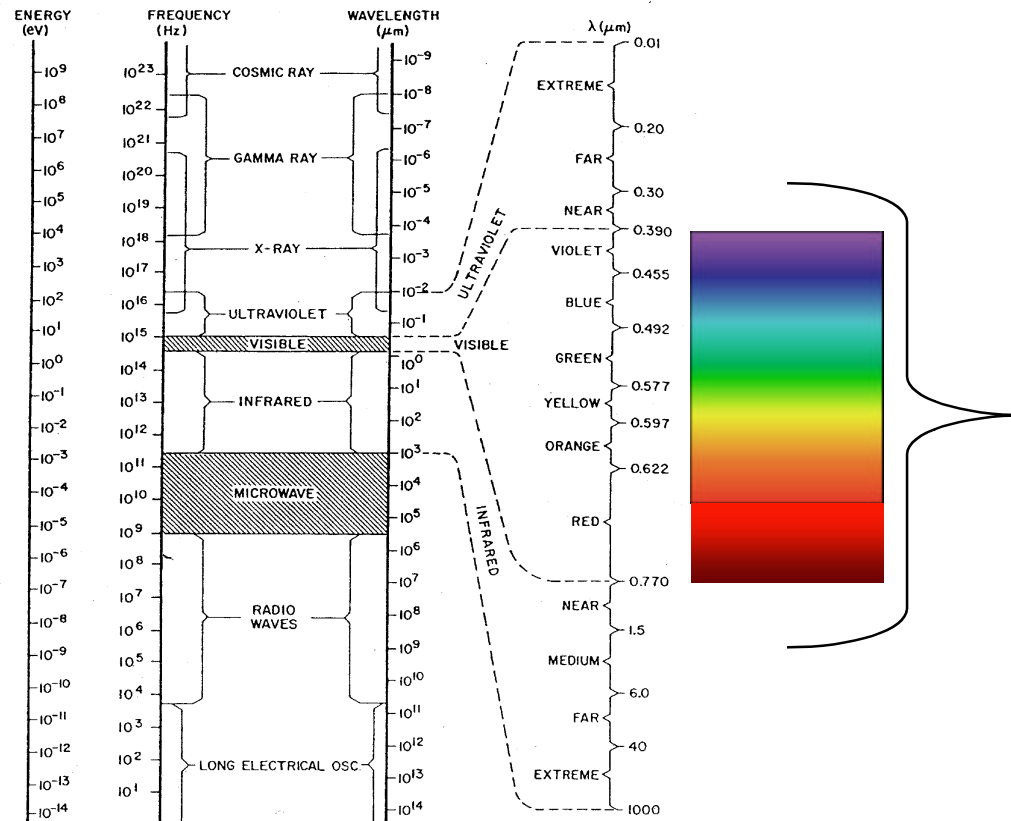


Klas Hjort, Materialvetenskap

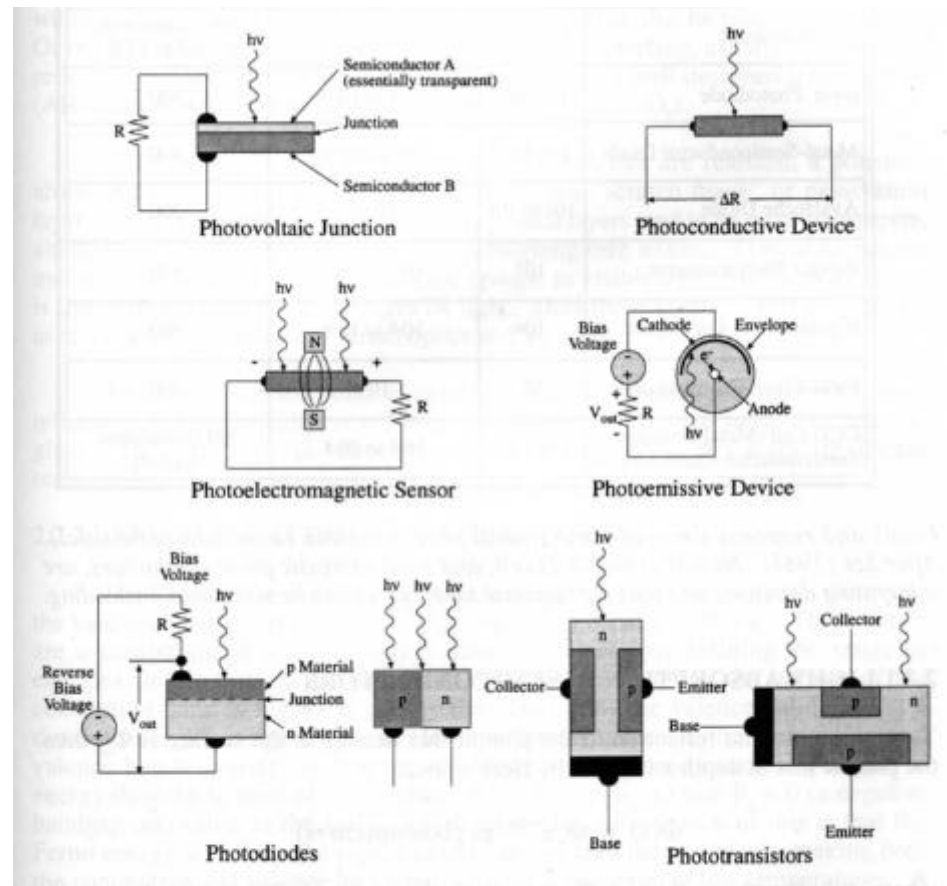
† Microsensors in The Optical Energy Domain

- Examples of microsensors in the optical energy domain
- Semiconductor physics
- Photodiodes
- Phototransistors
- Charge-coupled image sensors (CCDs)

Optical Energy Domain - Spectrum



Optical Energy Domain - Sensor Types



Optical Energy Domain - Definitions



Responsivity:

$$R_I = \frac{\text{output current}}{\text{optical input power}} = \frac{I_p}{P_{\text{opt}}} = \frac{\eta q}{h \nu} = \frac{\eta \lambda (\mu\text{m})}{1.2398}$$

where η is the quantum efficiency:

$$\eta = \frac{\left(\frac{I_p}{q} \right)}{\left(\frac{P_{\text{opt}}}{h\nu} \right)}$$

Detectivity:

$$D^* \equiv \frac{\sqrt{A}}{\text{NEP}} \quad \text{in} \quad \frac{\text{cm}\sqrt{\text{Hz}}}{\text{W}}$$

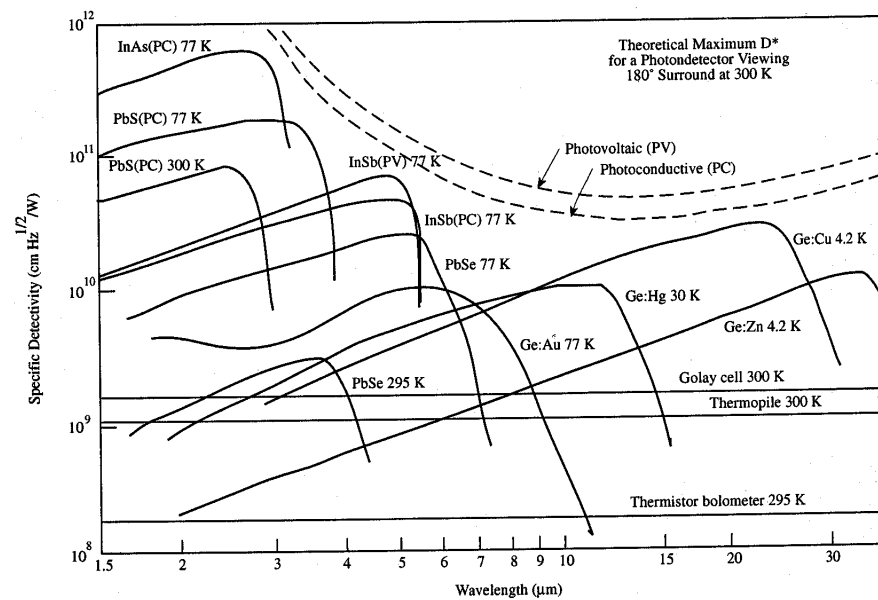
where the NEP is the noise equivalent power:

$$\text{NEP} \equiv \frac{\text{RMS noise current} \left(\frac{\text{A}}{\sqrt{\text{Hz}}} \right)}{R_I \left(\frac{\text{A}}{\text{W}} \right)} \quad \text{in} \quad \left(\frac{\text{W}}{\sqrt{\text{Hz}}} \right)$$

or, for a voltage-output device as,

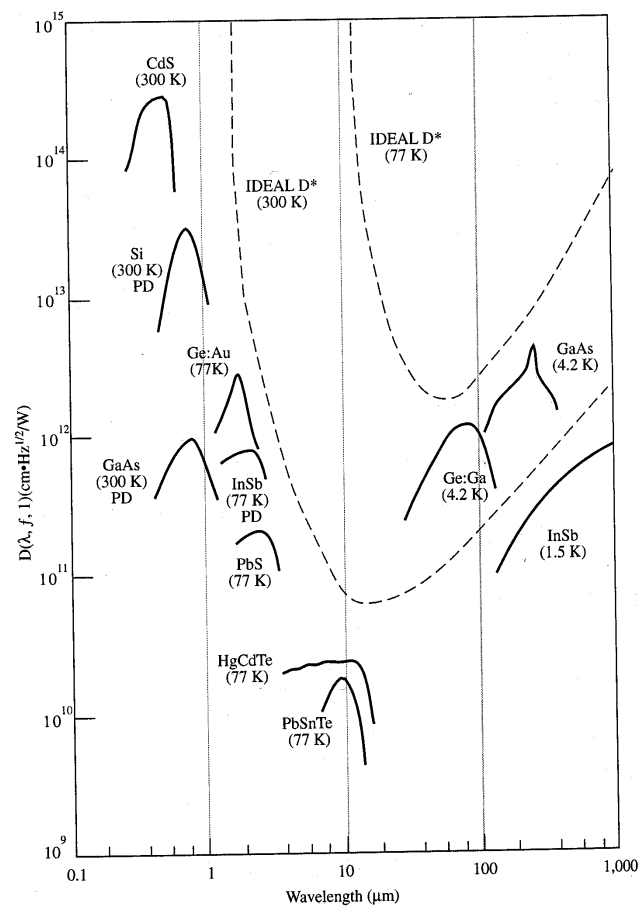
$$\text{NEP} \equiv \frac{\text{RMS noise voltage} \left(\frac{\text{V}}{\sqrt{\text{Hz}}} \right)}{R_V \left(\frac{\text{V}}{\text{W}} \right)} \quad \text{in} \quad \left(\frac{\text{W}}{\sqrt{\text{Hz}}} \right)$$

Optical Energy Domain - Physics



Plots of detectivities of various detectors, including Golay cells, thermopiles, and bolometers for comparison. After Cobbold (1974). Photovoltaic and photoconductive devices are identified as "PC" and "PV," respectively.

Optical Energy Domain - Physics



Optical Energy Domain - Physics



† Interaction of electromagnetic radiation with semiconductors

- When a photon with energy $E_{ph} > h\eta = E_g$ coincides with a semiconductor an electron-hole pair is generated
- The absorption is a function of temperature that can be described with

$$\Phi(x) = \eta \cdot \Phi_0 \cdot \exp(-\alpha \cdot x)$$

where: η - fraction of photons that coincide at the surface
 α - absorption coefficient

- Bandgap distance
 - » Si - 1.15 eV
 - » GaAs - 1.43 eV

Optical Energy Domain - Physics



† Influence of temperature and radiation on conductivity

In a p - n junction the number of electron-hole pairs per unit volume determines the conductivity S

The influence of temperature can be expressed in general as

$$S_T = q[n(T)\mu_n(T) + p(T)\mu_p(T)] \quad \text{where} \quad S_T (\Omega^{-1}m^{-1})$$

where: n, p - density of charge carriers

μ - mobility of the charge carriers

The increase of conductivity due to the radiation can be expressed in general as

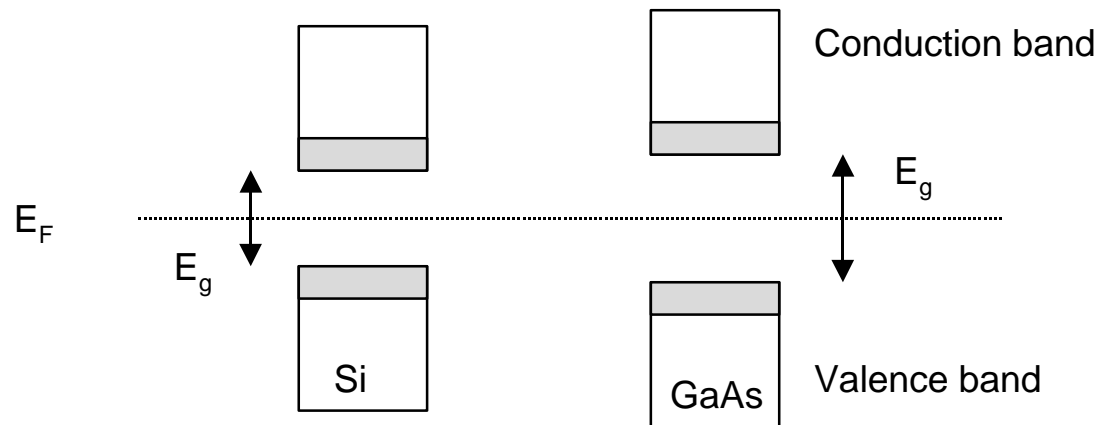
$$S_I = q[n(I)\mu_n + p(I)\mu_p]$$

$$S = S_T + S_I$$

Optical Energy Domain - Physics



† Interaction of electromagnetic radiation with semiconductors



E_F - Fermi level

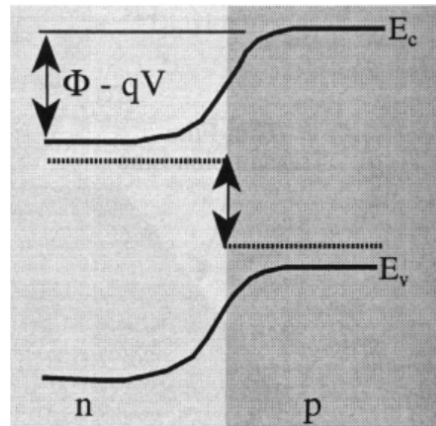
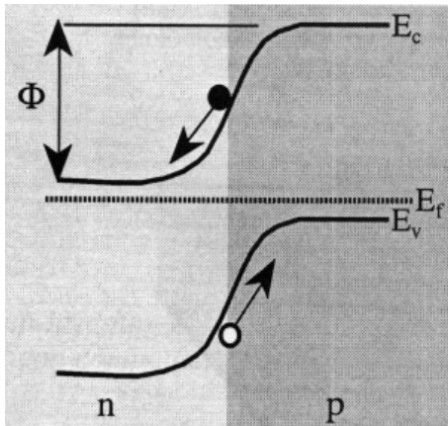
E_g - bandgap distance (Si - 1.15 eV, GaAs - 1.43 eV)

Optical Energy Domain - Physics

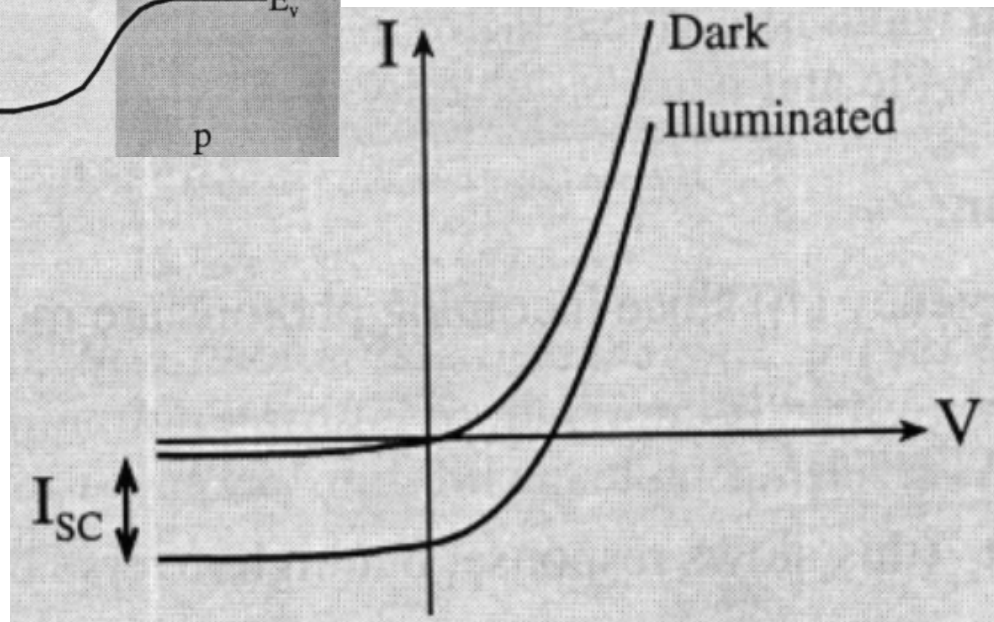


Semiconductor	Bandgap (eV) 300 K	Bandgap (eV) 0 K	λ_{max} (μm) 300 K
BN	7.500	-	0.165
C	5.470	5.480	0.227
ZnS	3.680	3.840	0.337
GaN	3.360	3.500	0.369
ZnO	3.350	3.420	0.370
Alpha-SiC	2.996	3.030	0.414
CdS	2.420	2.560	0.512
GaP	2.260	2.340	0.549
BP	2.000	-	0.620
CdSe	1.700	1.850	0.729
AlSb	1.580	1.680	0.785
CdTe	1.560	-	0.795
GaAs	1.420	1.520	0.873
InP	1.350	1.420	0.919
Si	1.120	1.170	1.107
GaSb	0.720	0.810	1.722
Ge	0.660	0.740	1.879
PbS	0.410	0.286	3.024
InAs	0.360	0.420	3.444
PbTe	0.310	0.190	4.000
InSb	0.170	0.230	7.294
Sn	-	0.082	15.122 @ 0 K

Optical Energy Domain - Physics



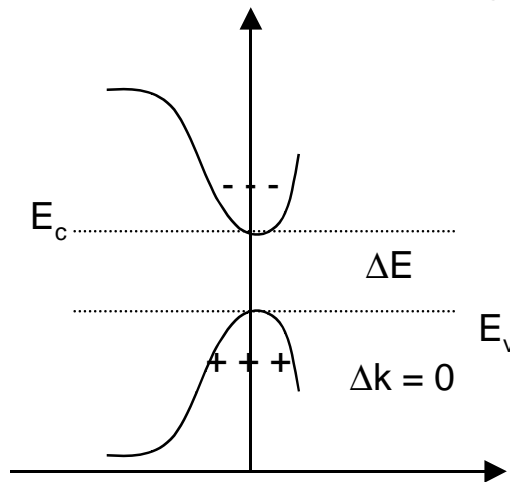
Generation of a voltage at a pn-junction by creating an electron-hole pair



Optical Energy Domain - Physics

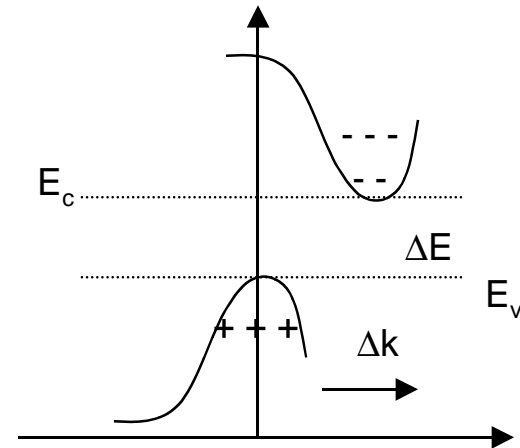


† Direct- and indirect- bandgap materials



GaAs

Transition requires
change in energy only



Si

Transition requires
change in energy and wave number

Optical Energy Domain - Physics



† Direct- and indirect- bandgap materials

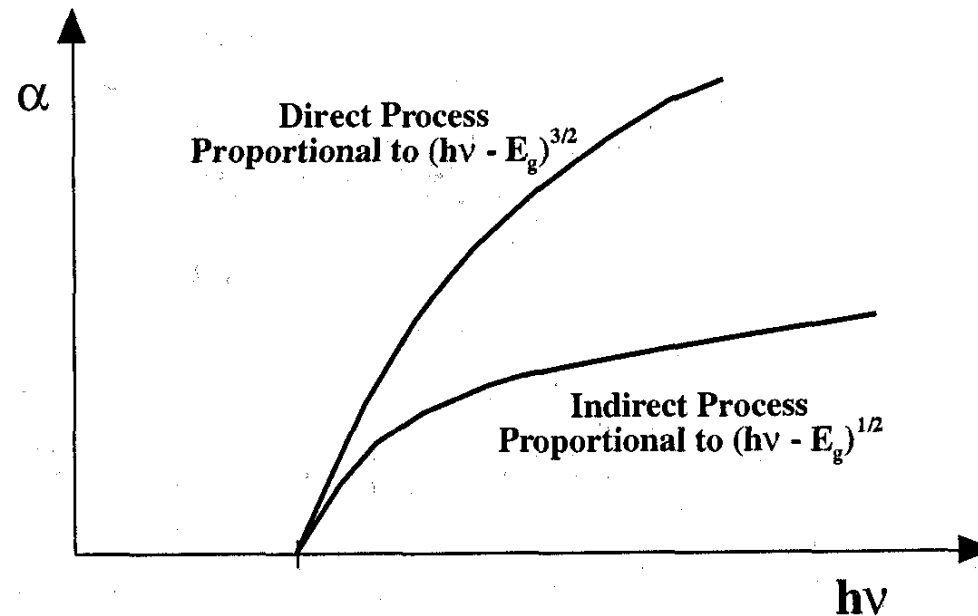
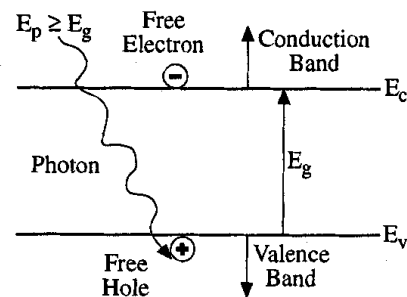


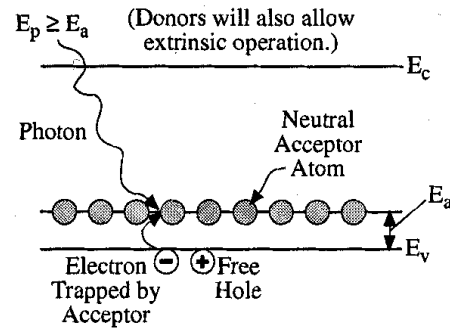
Illustration of the absorption spectra of direct and indirect processes.

Optical Energy Domain - Physics

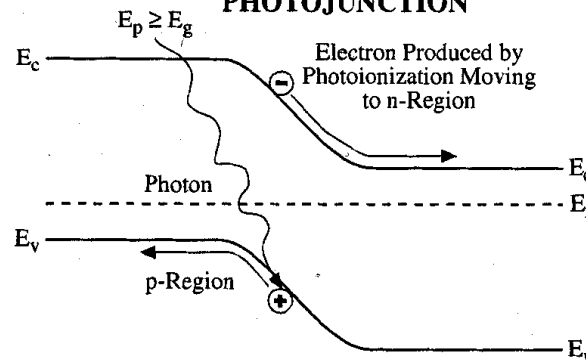
INTRINSIC PHOTOCONDUCTOR



EXTRINSIC PHOTOCONDUCTOR



PHOTOJUNCTION

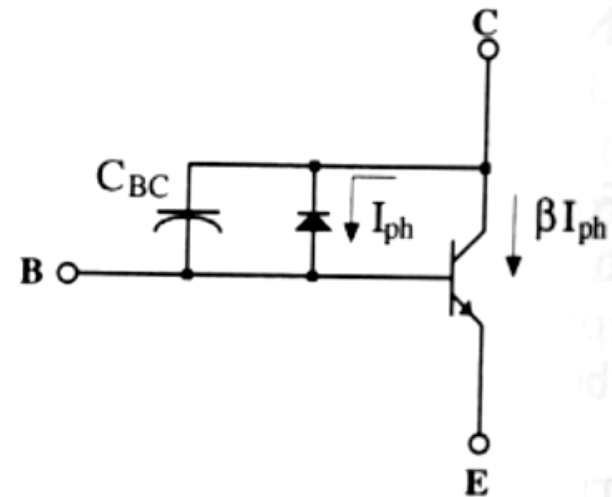
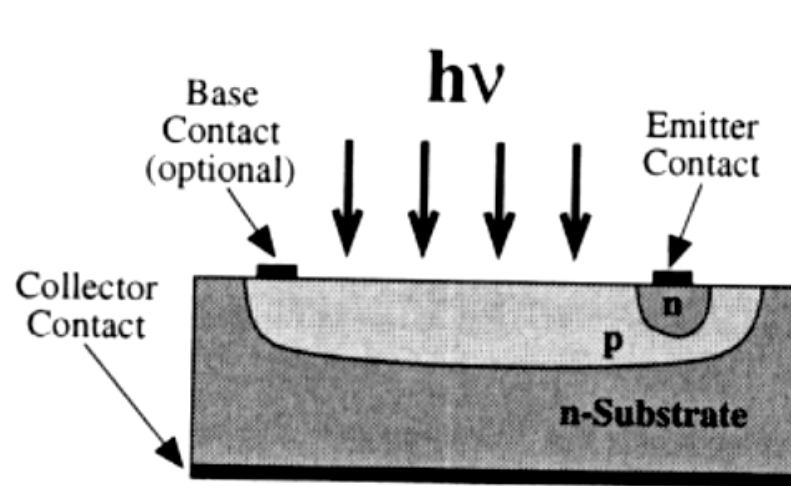


Comparative band diagrams for intrinsic-, extrinsic- and photojunction-type optical sensors. After Cobbold (1974).

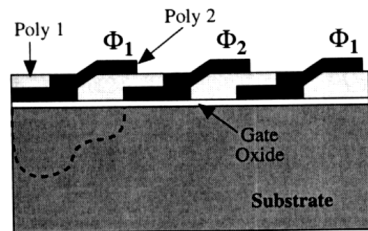
Optical Energy Domain - Physics



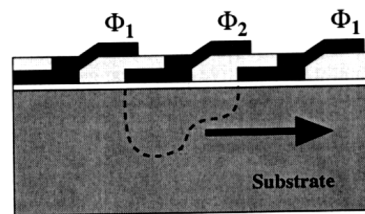
Phototransistors - bipolar



Charge-coupled image sensors (CCD)



Φ_1 Active



Φ_2 Active

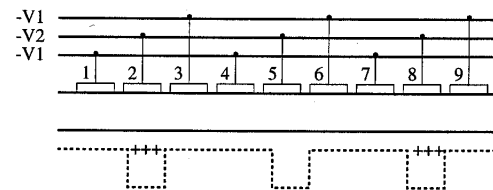
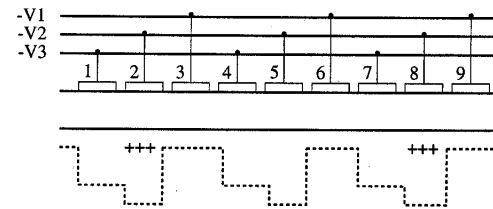
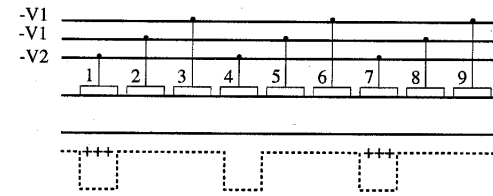


Illustration of operating mode of (older style) a three-phase CCD array showing the mechanism of the charge transfer between depleted MOS capacitors. Adapted from Millman (1979).